ESS502 Ceramic Piezo-Resistive Pressure Sensor Cell FLUSH DIAPHRAGM THCIK-FILM | AI2O3 96%



Range: 0~100bar/200bar
Size:18mm*6.35mm; 18mm*3.5mm
Diaphragm Material: Ceramic Al2O3 96%
Power Supply: 2-30V
Long Term Stability: 0.3%/FS
Temperature Compensation:-10...70°C
Working Temperature: -40...+135 °C

Description

ESS502 **Flush Diaphragm Pressure Sensor Cell** are made with a **Ceramic Base Plate and Diaphragm** and work following the piezoresistive principle. The Wheatstone bridge is **Screen Printed** on one side of the flush ceramic diaphragm which is, in turn, glued to the sensor's body. The bridge faces the inside where a cavity is made and the diaphragm's opposite side can therefore be exposed directly to the medium to be measured.

The Wheatstone bridge is screen printed directly on one side of the ceramic diaphragm by means of **Thick Film Technology**. Because of the **Al2O3 Ceramic** excellent chemical resistance (aggressive gases, most of solvents and acids, etc.), no additional protection is normally required. Thanks to the reinforced outer area (monolithic structure), the sensor can be mounted directly in a plastic or metallic case by using O-ring.

ESS502 Flush Diaphragm Pressure Sensor Cell are available with two kind size: 18*6.35mm and 18*3.5mm (thin type), both are thermally compensated by laser-adjustable PTC resistors and the use of ceramic ensures a high linearity across the entire range of measurement, reducing effects of hysteresis to a minimum.

Key Features & Benefits

- Pressure range 0-5bar-100bar/200bar
- Excellent resistance to corrosion and abrasion
- Absolute measurement available
- Thermally compensated
- Extended customization
- Extended choice of measuring ranges

Application

- Cooling equipment & A/C system
- Automotive and vehicle
- Industrial process control
- HVAC system
- Refrigeration equipment
- Air conditioning unit

Technical Characteristics

Parameter	Unit	Description
Sensor type	-	Flush diaphragm, absolute (A), gauge (R) or sealed gauge (S)
Technology	-	Piezoresistive (Ceramic Thick Film)
Diaphragm material	-	Ceramic Al ₂ O ₃ 96% (standard), 99.6% or sapphire (on request)
Weight	g	≤ 8 (ceramic cell only)
Response time	ms	≤1
Supply voltage	VDC	230

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Offset		mv/v	- 0.1 ± 0.1 (Other nominal values available on request)											
Current cons.		mA	≤ 1.3 @ 10V											
Operating temp	erature	°C					-40+13	35 (-40 °F.	.+275 °F)					
Storage temper	ature	°C	-40+150 (-40 °F+302 °F)											
Impedance Nominal bar		kΩ	11 ± 30%											
Nominal pressure FSO	bar	0.5*	1*	2*	5	10	20	50	100	200 *	400 *	600 *	800 *	
	psi	7	14	29	73	145	290	725	1450	2900	5800	8700	11600	
Overload	bar	1	2	4	10	15	35	100	150	350	500	750	750 1000 10875 14500 950 1250	
ressure	psi	14	29	58	145	217	507	1450	2175	5075	7250	10875	14500	
Burst pressure	bar	2	3	6	15	25	65	120	200	500	650	950	1250	
	psi	29	43	87	217	362	942	1740	2900	7250	9425	13775	18125	
Vacuum capability	bar	-0.1	-0.5	-0.5	-1	-1	-1	-1	-1	-1	-1	-1	-1	
	psi	-1.4	-7	-7	-14	-14	-14	-14	-14	-14	-14	-14	-14	
Туре	-	R	A/R/S	A/R/S	A/R/S	A/R/S	A/R/S	A/R/S	S	S	S	S	S	
Total thickness	mm/in				6.30± 0.05	6.35± 0.05	6.45± 0.05	6.65± 0.05	6.78± 0.05	6.95± 0.05				
	mm/in				3.30± 0.05	3.30± 0.05	3.35± 0.05	3.45± 0.05	3.78± 0.05	for thin type				
Sensitivity 2	mv/v				2.3-4.0	3.1-5.5	2.4-4.0	4.0-6.0	3.0-4.8	2.5-3.9				
Accuracy 3 Thermal offset shift	%/fs				0.2/0.4	0.2/0.5	0.2/0.5	0.2/0.5	0.2/0.5	0.4/0.9				
Thermal offset shift(typ./max.)	%/fs/k	± 0.0	0.205 / ± 0.040 25 °C85 °C (77 °F185 °F)									-		
Thermal span shift	%/fs/k	≤ ± 0						(32 °F158 °F) : / 70 °C85 °C (-13 °F32 °F / 158 °F185 °F) °C / 85 °C135 °C (-40 °F13 °F / 185 °F275 °F)						
Reliability tests 4	-	- 1000 hours @85 °C (185 °F) & 85 %RH 1000 hours burn-in @150 °C (302 °F)							500 thermal shocks -40°C+150 °C (-40 °F +302 °F) 10 million 0 bar to Pnom pressure cycles					

Tests performed at 25°C in Eastsensor housings, unless otherwise specified. Different housings may affect performances.

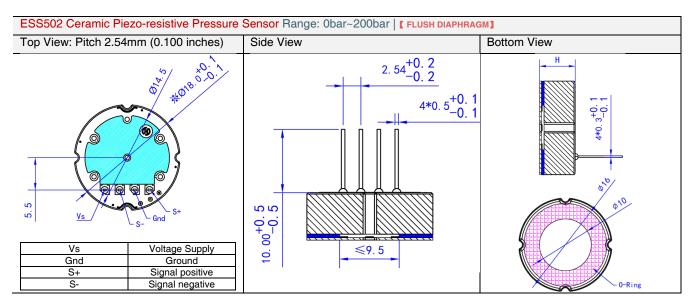
1. Psi values for reference only.

2. The sensitivity of each production batch is constant, within the indicated range and with minimal dispersion.

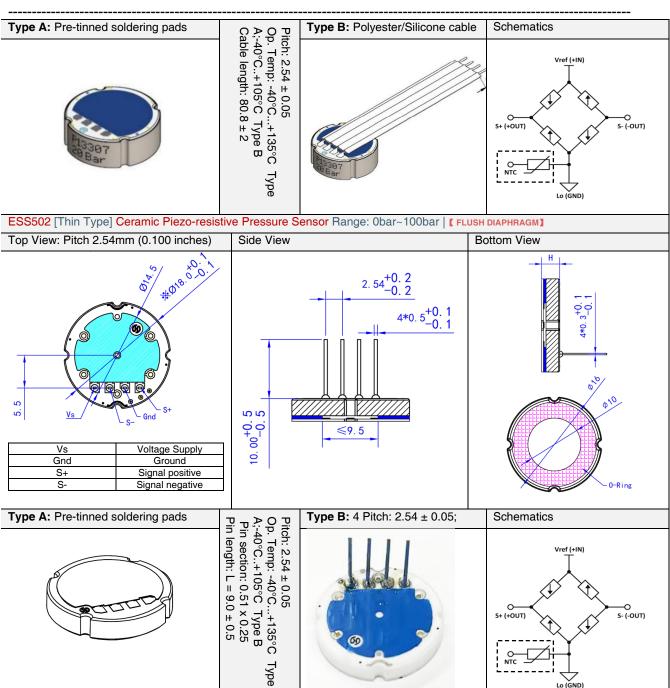
 $3. Accuracy = \sqrt{NonLinearity^2 + Hysteresis^2 + NonRepeatability^2}, terminal based.$

All technical characteristics will remain within indicated ranges performing the above-mentioned reliability tests.
Please consult manufacturer when pressure range with **

Drawing



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1. Storage Conditions: Store at 10~35°C with ≤70% RH. Avoid places that are too hot, exposed to direct sunlight, dusty, or have corrosive gases. The metal pins can easily oxidize in the air, so it's recommended to use the product within 10 days after unpacking. Under proper storage conditions, the soldering validity is 12 months. If stored for more than 12 months, the ceramic core needs to be rechecked for solderability and can only be used if it passes inspection.

2. Product Installation Pressure: During crimping installation, the crimping pressure should not exceed 20KN, and the direct pressure on the core should not exceed 5KN. Excessive force may damage the core structure or cause abnormal output signals. The ceramic core should not come into direct contact with hard objects like a metal casing to avoid significant internal stress and unstable output.

3. Sealing Recommendations: When using sealing rings, ensure that the sealing ring is centered with the elastic diaphragm and without uneven force. The inner diameter of the sealing ring should be >10.0mm and the outer diameter <16.0mm after compression deformation.

4. Solder Pads: The pressure core PIN is constructed of nickel-tin copper. The welding hole for the PIN measures 0.8mm, with a pad width exceeding 0.5mm. The soldering temperature must not exceed 370 C, with each soldering session limited to under 3 seconds and a maximum of 3 sessions.

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Ordering Procedure

ESS5	Ceramic Piezoresistive Pressure Sensor												
	Cod	le	Model										
	01			Pressure Sensor Cell, Monolithic 18*6.35mm									
	01 T	hin				r Cell, Monolithic 18*3.35mm							
	01-l									Electronics on PCB			
	01-\							• •	,	Electronics on PCB			
	01-II	С	Pressure Sensor Module, Monolithic (with pcb) I2C Output; Electronics on PCB										
	02		Pressure Sensor Cell, Flush diaphragm 18*6.35mm										
	02 T	hin	Pressure Sensor Cell, Flush diaphragm 18*3.35mm										
	02-I		Pressure Sensor Module, Flush diaphragm (with pcb) 4-20mA; Electronics on PCB										
	02-10	C	Pressure Sensor Module, Flush diaphragm (with pcb) 4-20mA; Electronics on Ceramic										
	02-\	/	Pressure Sensor Module, Flush diaphragm (with pcb) 0.5-4.5V; Electronics on PCB										
	02-\	/OC	Pressure Sensor Module, Flush diaphragm (with pcb) 0.5-4.5V; Electronics on Ceramic Pressure Sensor Module, Flush diaphragm (with pcb) I2C Output; Electronics on PCB										
	02-II	С											
	02-II	COC											
	03				re Sensor Cell (with temperature sensor mounted), Monolithic 18*6.35mm								
	03 1	Thin	Pressure Sensor Cell (with temperature sensor mounted), Monolithic 18*3.35mm										
			Code	Spa	n			Code	Span				
			R01	00	.5 bar	[07	'psi]	R07	050 bar	[0720psi]			
			R02	01		[01		R08		[01450psi]			
			R03	02	bar		9psi]	R09	0200 bar	[02900psi]			
			R04	05	05 bar [072psi]			R10	0400 bar	[05800psi]			
			R05	01	0 bar	-	145psi]	R11	0600 bar	[08700psi]			
			R06	02	0 bar		290psi]	R12	0800 bar	[011600psi]			
				Cod	e Pi		re Type						
				R		auge							
				А		Absolute							
				S	S	ealed	Gauge						
						ode	-	ty adjustme	ent				
					0		Without						
					9		On request						
							Code	Therma	loffset				
							0			ermally compensated)			
							1	$\leq \pm 0.00 \%$ $\leq \pm 0.04 \%$					
							2		0.02 % FS/K				
							-	Code					
				Code Termination type 02 4 pins, Pre-tinned pads, pitch 2.54 million									
								02		one single wires 80 mm, pitch 2.54 mm			
								00	Code	Additional coating			
									1				
1									2	Without			
								1		Parylene coating			

Note: Settembly attention must be paid to sensor installation process to avoid any miss conduction that affect the sensor performance, please protect the diaphragm and the compensated board carefully to prevent any damage. Please contact us if your requested working temperature lower than -20 C;